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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

AC None

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

AC REPUBLIC OF KOREA 2003-17597 03/20/2003

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 7	TOTAL CLAIMS 6	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met/ Verified and Acknowledged				
<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature: <u>Hwang, Sun-Lee</u> Initials: <u>CS</u>				

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## TITLE

Method of aligning a semiconductor substrate with a semiconductor alignment apparatus

FILING FEE  RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____
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